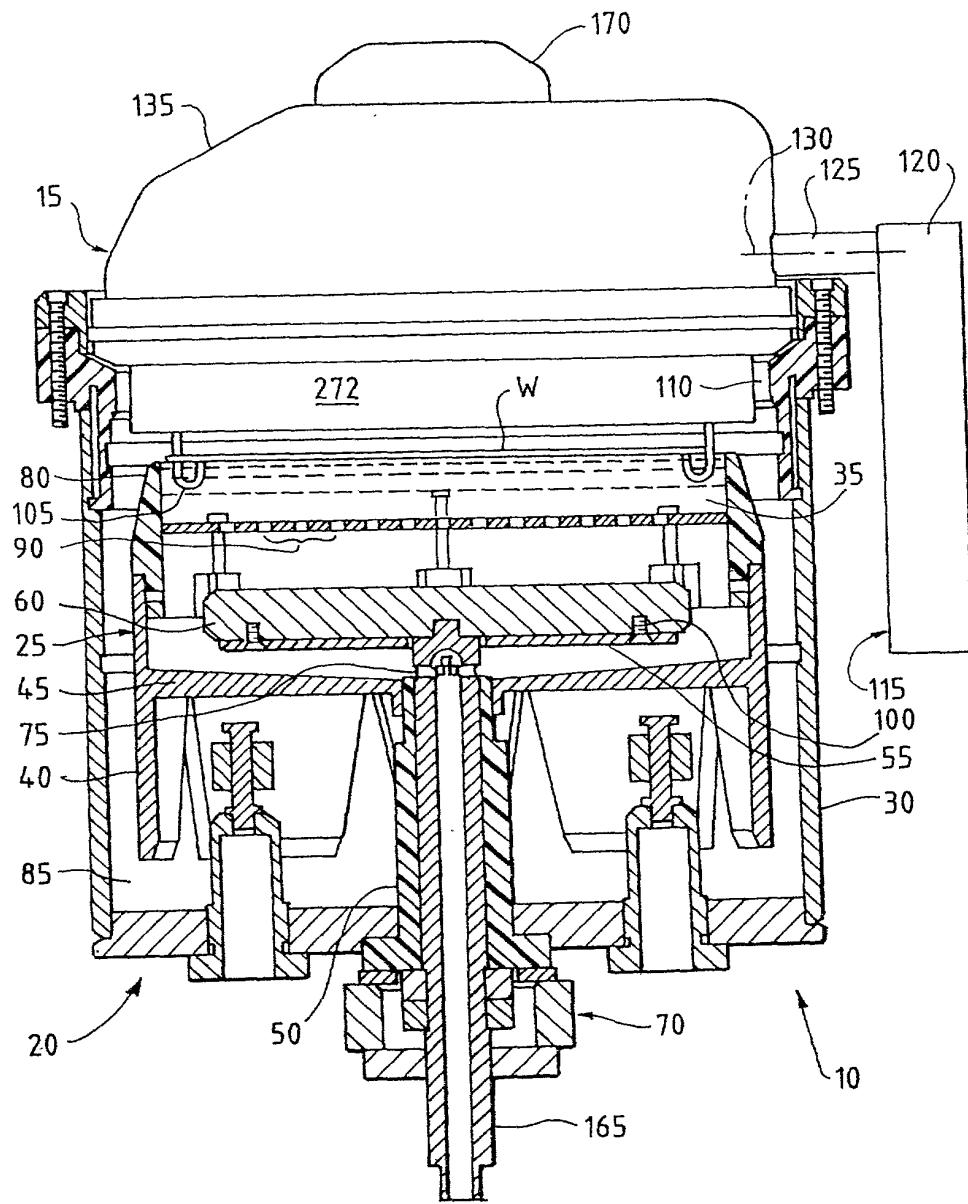


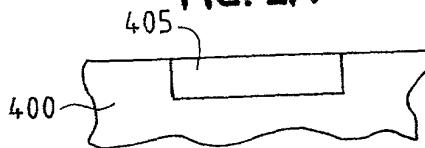
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FIG. 1

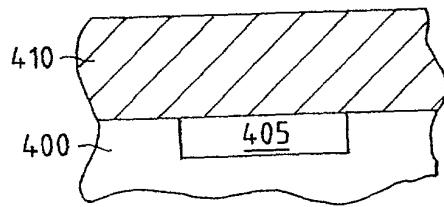


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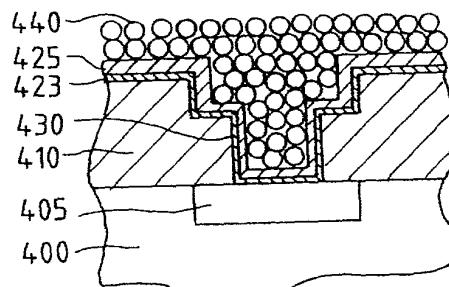
**FIG. 2A**



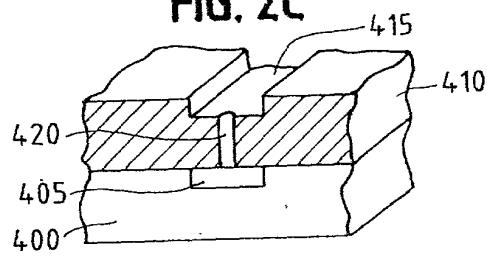
**FIG. 2B**



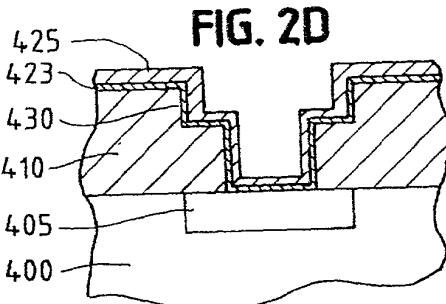
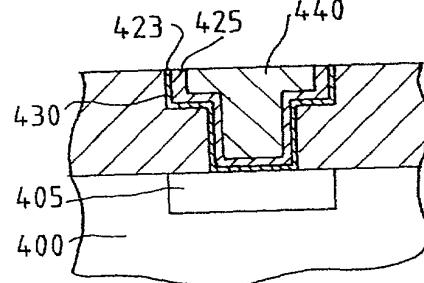
**FIG. 2E**



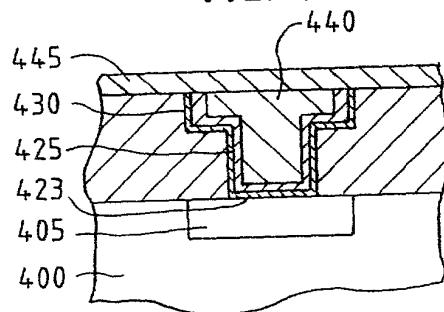
**FIG. 2C**



**FIG. 2F**



**FIG. 2G**



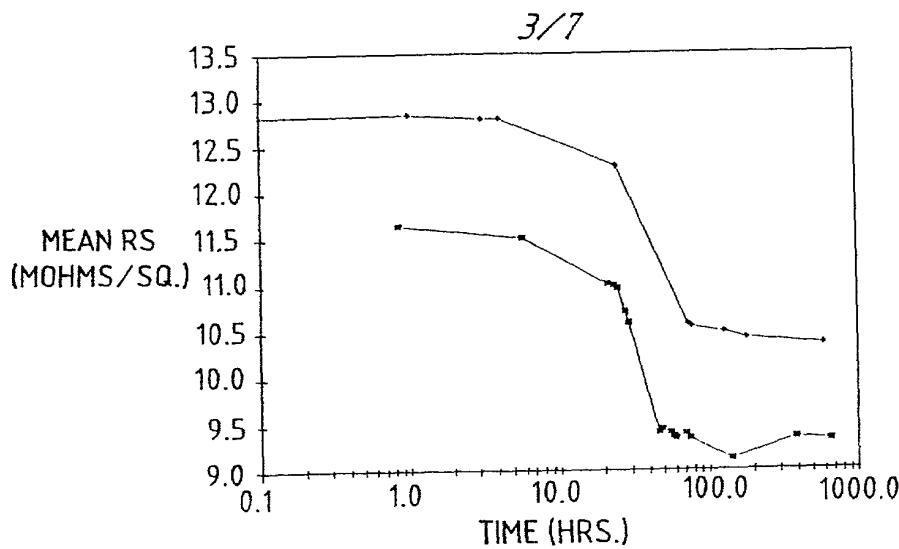


FIG. 3

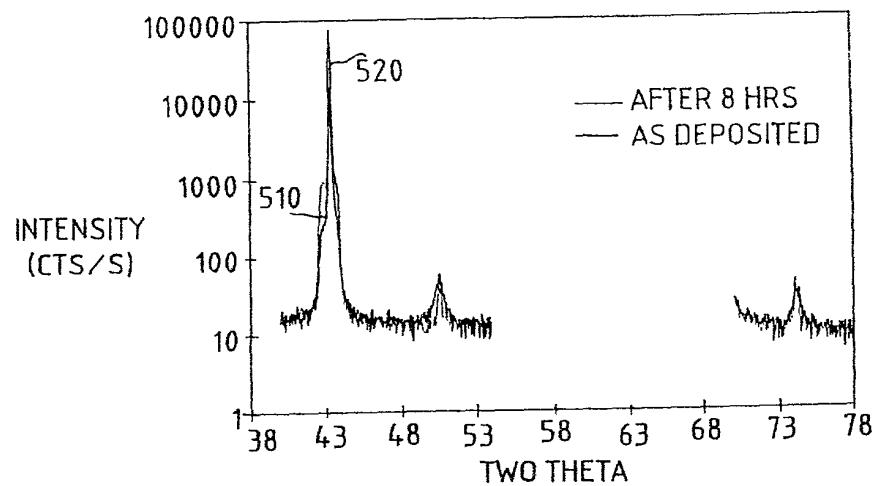


FIG. 4

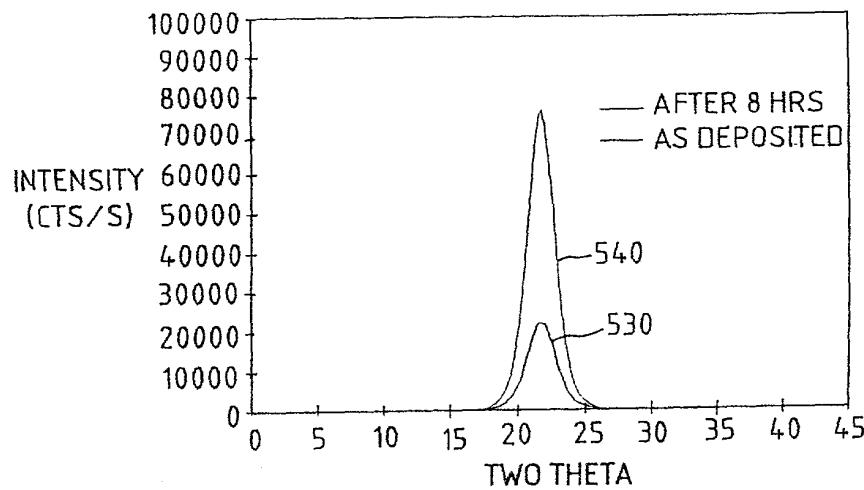


FIG. 5

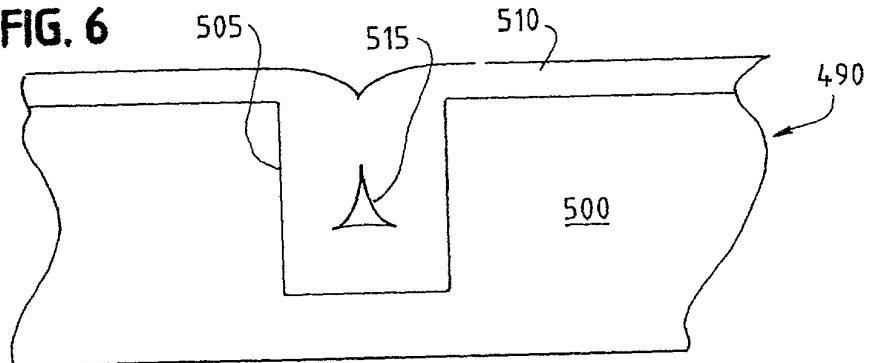
Title: METHOD AND APPARATUS FOR LOW TEMPERATURE  
ANNEALING OF METALLIZATION MICROSTRUCTURES IN THE  
PRODUCTION OF A MICROELECTRONIC DEVICE

Inventors: T.L. Ritzdorf et al.

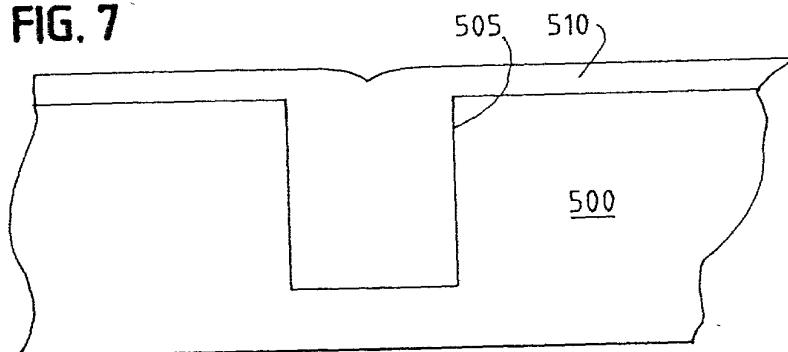
Docket No.: SEMT116123

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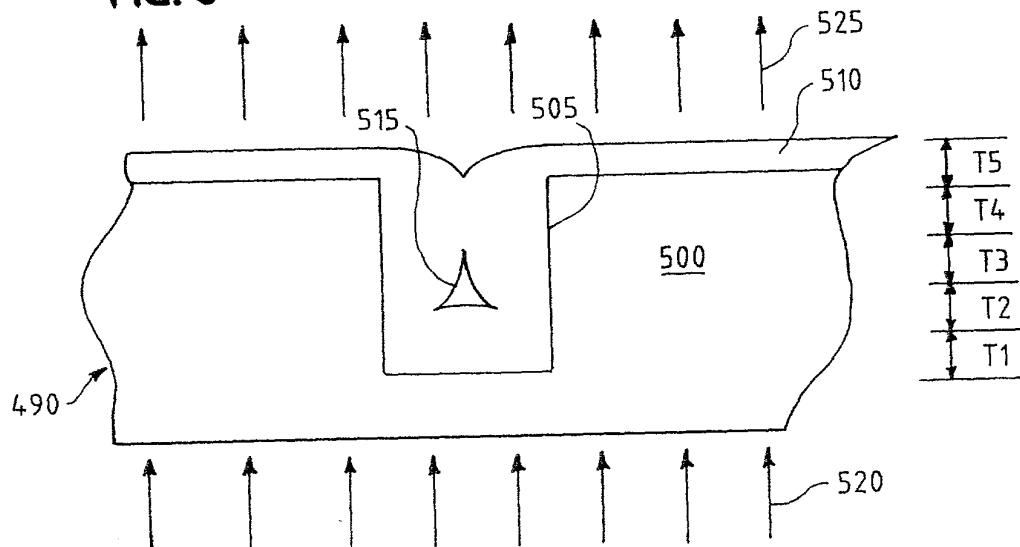
**FIG. 6**



**FIG. 7**



**FIG. 8**



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ANNEALING OF METALLIZATION MICROSTRUCTURES IN THE  
PRODUCTION OF A MICROELECTRONIC DEVICE

Inventors: T.L. Ritzdorf et al.

Docket No.: SEMT116123

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FIG. 9

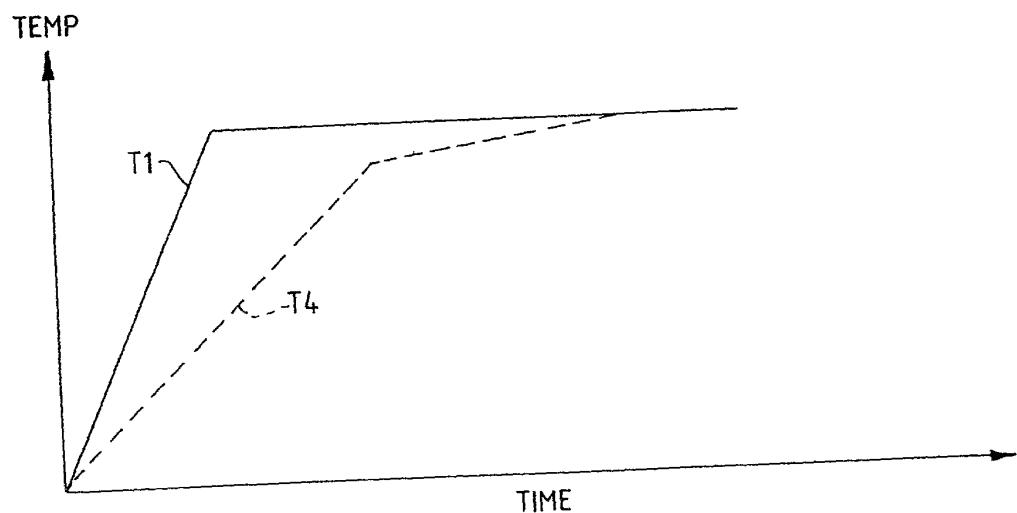
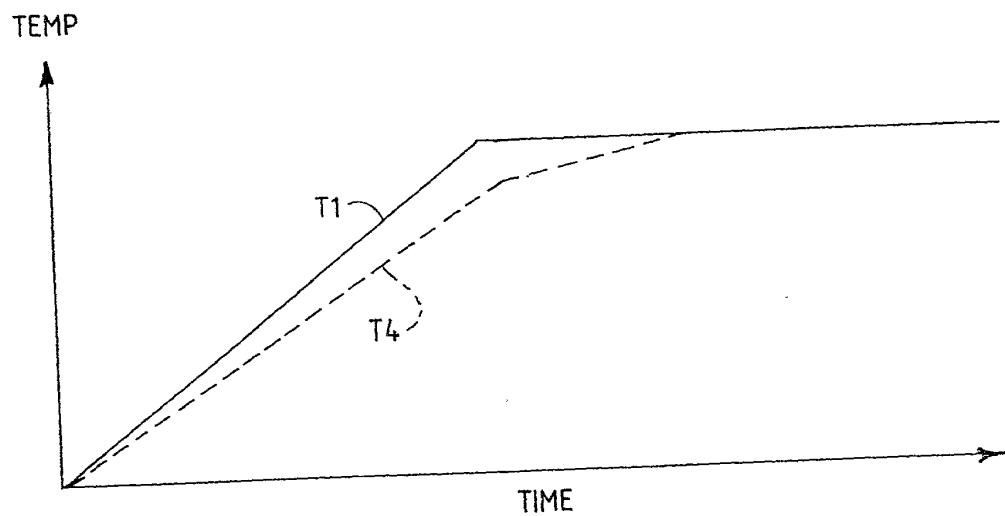
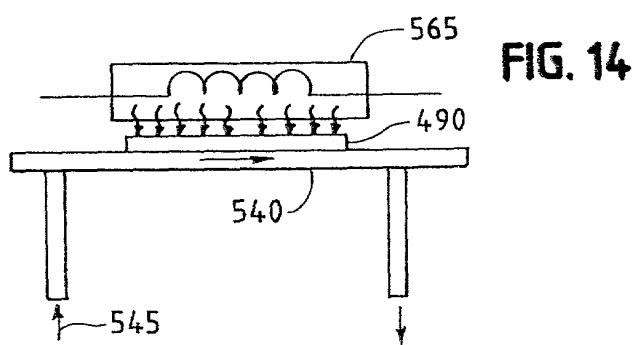
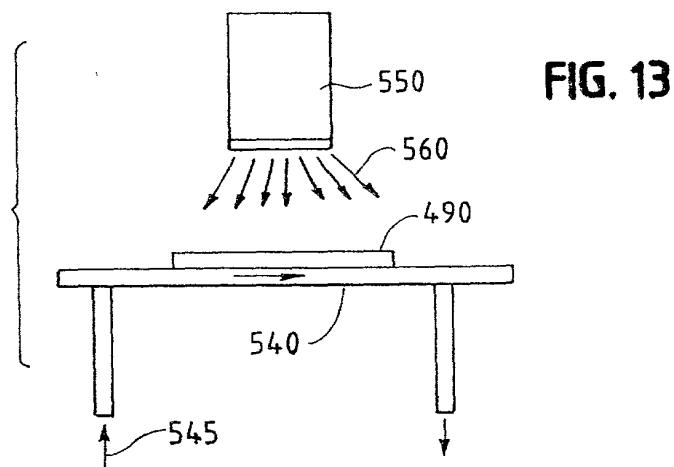
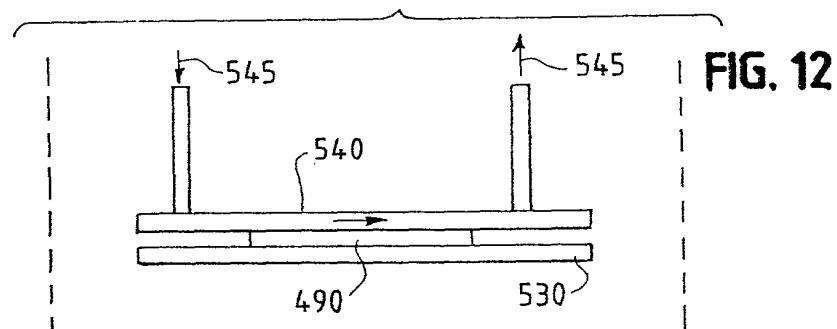
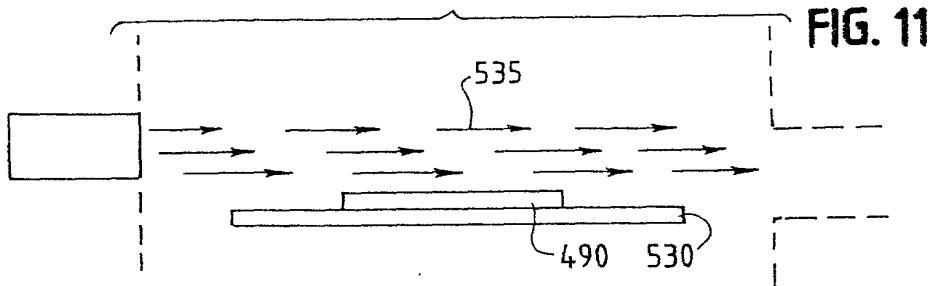


FIG. 10



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FIG. 15

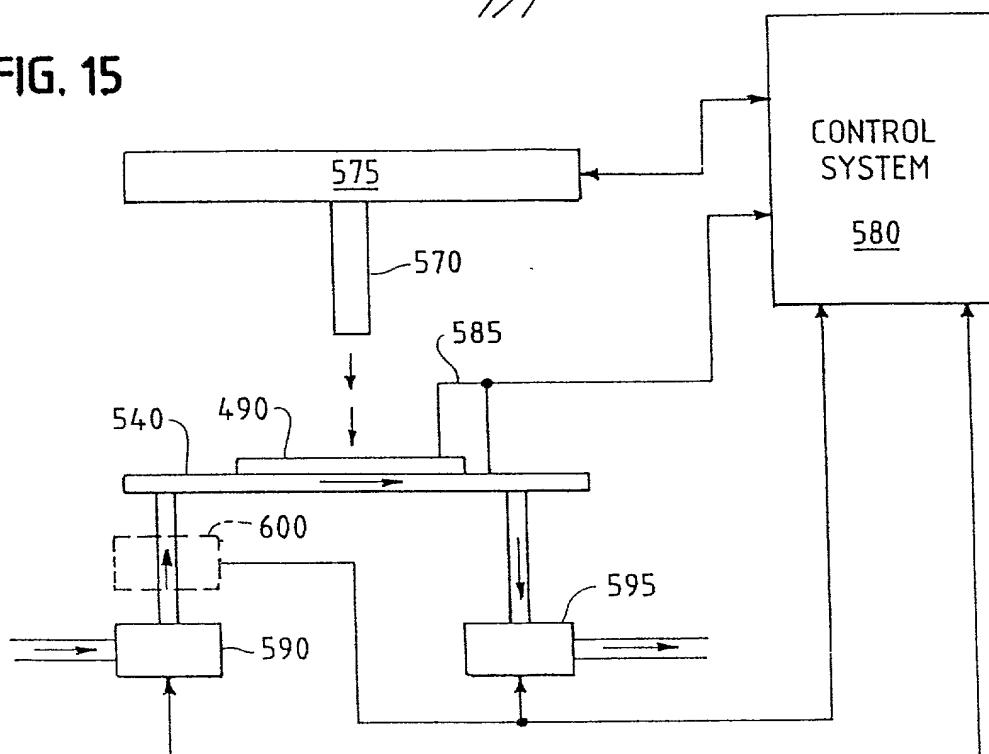


FIG. 16

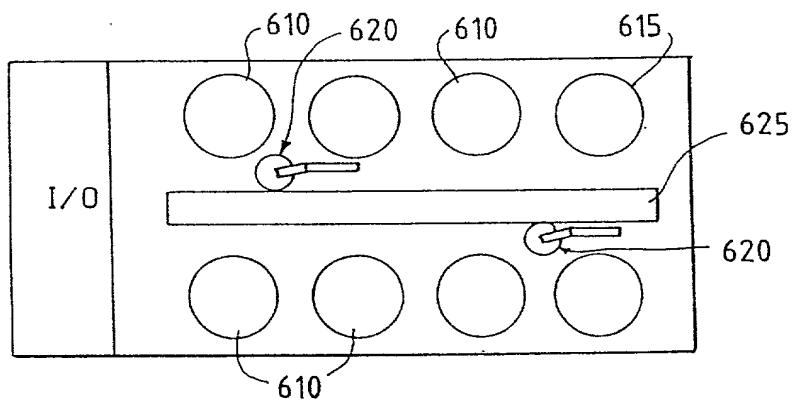


FIG. 17

